



O.I.P.E.		PATENT DATE
SCANNED <i>[Signature]</i>	G.A. <i>[Signature]</i>	

APPLICANTS	APPLICATION NO. 09/609347	CONT/PRIOR D	CLASS 204	SUBCLASS	ART UNIT 1741	EXAMINER
	Robin Cheung Ashok Sinha Avi Terman Dan Carl				212	1753
TITLE	Apparatus for electro chemical deposition of copper metallization with the capability of in-situ thermal annealing					

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[illegible]

<input checked="" type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)		NOTICE OF ALLOWANCE MAILED	
<input checked="" type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent No. <u>6,136,163</u>	_____ (Primary Examiner) (Date)		ISSUE FEE	
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